



### Communications—A New Section in *Optical Engineering*

I am pleased to announce a new section of our journal that appears in this month's issue. The section is called "Communications" and will be included as needed as a separate section following the technical papers.

The purpose of this new section is to publish short communications on original work, comments on recent papers, and errata. It will be my responsibility to determine what material is accepted for publication and, when necessary, I will seek outside reviewers' assistance. This is not meant to be a "letter to the editor" section where writers comment on issues of the day, whether political or scientific. Contributions must be technical in nature and add something positive to our further understanding of our field of optical science and engineering.

I encourage your submissions to our new "Communications."

### Electronic Imaging—A New Journal

I am pleased to bring a new journal to your attention. This new publication, called the *Journal of Electronic Imaging*, is copublished by SPIE—The International Society for Optical Engineering and IS&T—The Society for Imaging Science and Technology. The first issue of this new journal was published in time for the Symposium on Electronic Imaging Science and Technology held in San Jose, California, February 9–14, 1992. Like the *Journal of Electronic Imaging*, the conference was cosponsored by SPIE and IS&T.

We welcome Editor Paul Roetling and Associate Editor Majid Rabbani to the brotherhood of editors. I will be working closely with Paul to ensure that the right papers appear in the right journals.

The *Journal of Electronic Imaging* will appear quarterly and cover all technology areas that make up the field of electronic imaging and are normally considered in the design, engineering, and application of an electronic imaging system. The following research areas, whether they apply directly to electronic imaging or focus on applied electronic imaging technology, will be covered:

- Image acquisition
- Image data storage
- Image data communication
- Display of image data
- Hard copy output
- Image visualization
- Image processing
- Electronic imaging application.

The *Journal of Electronic Imaging* has been created in response to the need for a refereed journal dedicated to technical problems, issues, and progress in the field of electronic imaging. Its objective is to address the full spectrum of electronic imaging technologies from the standpoint of technical innovation, systems integration, and application, and therefore meet the needs of readers and authors working in this field.

The two societies, SPIE and IS&T, and the editors of the new journal invite your active participation as both reader and author. Manuscripts should be submitted to:

Paul G. Roetling  
*Journal of Electronic Imaging*  
 Xerox Webster Research Center  
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 800 Phillips Road  
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**Brian J. Thompson**  
 Editor

## May 1992

### Optical Implementation of Information Processing, Pattern Recognition, and Neural Networks

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## June 1992

### Adaptive Signal Processing

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## August 1992

### Optical Engineering and U.K. Industry

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## September 1992

### Wavelet Transform

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## October 1992

### Acousto-Optics

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## November 1992

### Relay Mirror Experiment

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## December 1992

### Automatic Target Recognition

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## January 1993

### Optical Research in Asia

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## February 1993

### Biomedical Optics

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*Manuscripts due June 15, 1992.*

## March 1993

### Optical Fiber Reliability II

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*Manuscripts due July 15, 1992.*

## April 1993

### Emerging Optoelectronic Technologies

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*Manuscripts due Sep. 1, 1992*

## May 1993

### Phase Contrast Microscopy

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*This special issue is connected with an international conference on Phase Contrast (PhC) and Differential Interference Contrast Microscopy, scheduled Oct. 19-21, 1992, in Warsaw, Poland, and organized by the Polish Chapter of SPIE. Topics will include theory and practice of phase micro-objects visualization, instrumentation for PhC microscopy, quantitative PhC techniques, linear phase microscopy, laser scanning differential PhC microscopy,*

*scanning tunneling microscopy of phase objects, and new applications in biology/biomedicine and materials sciences. Manuscripts due Oct. 1, 1992.*

## June 1993

### From Numerical to Symbolic Image Processing: Systems & Applications

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*This special issue will present innovative research and results on the integration between numerical and symbolic processing. Examples covering real applications will be considered. Manuscripts due Oct. 15, 1992.*

## July 1993

### Visual Communication and Image Processing IV

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*Manuscripts due Dec. 1, 1992.*

## September 1993

### Optical Science and Engineering in Canada

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*Manuscripts due Feb. 1, 1993.*

## October 1993

### Microlithography

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*This issue will cover the range of topics found in the SPIE Symposium on Microlithography (San Jose, Calif.), including resist materials, optical systems, and metrology. Manuscripts due March 1, 1993.*

## November 1993

### Acquisition, Tracking, and Pointing

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*Manuscripts due April 1, 1993.*